Overview of optical plasma diagnostics for novel accelerators





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Lay out of the presentation

-) Introduction: Scope and Motivations

-) Optical density diagnostics and application examples

-) Conclusions

NOTE - Content adapted from:

F. Brandi and L. A. Gizzi, High Power Laser Sci. Eng. 7, e26, 2019

Scope

-) An <u>overview of optical based diagnostics</u> to measure and monitor the <u>background plasma density</u> in plasma acceleration stages:

- *Free expanding gas jet* (subsonic and supersonic)
- *Flowing gas cell* (continuous flow or pulsed)
- Plasma channels (laser produced and capillary discharges)

-) Diagnosis of the <u>Plasma wake</u> and of the <u>electron bunch</u> is of critical importance. The issue is treated in details in a number of recent works:

PHYSICAL REVIEW X 9, 011046 (2019), M. F. Gilljohann, H. Ding, A. Döpp, J. Götzfried, S. Schindler, G. Schilling, S. Corde, A. Debus, T. Heinemann, B. Hidding, S. M. Hooker, A. Irman, O. Kononenko, T. Kurz, A. Martinez de la Ossa, U. Schramm, and S. Karsch

Rev. Mod. Phys. 90, 035002, 2018, M. C. Downer, R. Zgadzaj, A. Debus, U. Schramm, and M. C. Kaluza.

Physics of Plasmas 25, 056704 (2018), A. Cianchi, M. P. Anania, F. Bisesto, E. Chiadroni, A. Curcio, M. Ferrario, A. Giribono, A. Marocchino, R. Pompili, J. Scifo, V. Shpakov, C. Vaccarezza, F. Villa, A. Mostacci, A. Bacci, A. R. Rossi, L. Serafini, and A. Zigler

Free-electron density in plasma

Density measurement is Ubiquitous in all Plasma applications

- -) <u>Debye length</u>: $\lambda_{D} = [\epsilon_{0}K_{B}T/e^{2}N_{e}]^{1/2}$
- -) <u>Plasma frequency</u>: $\omega_{p} = [N_{e}e^{2}/m_{e}\epsilon_{0}]^{1/2}$
- -) <u>Refractive index</u>: $n = [1 (\omega_p/\omega)^2]^{1/2} \simeq 1 \frac{1}{2} (\omega_p/\omega)^2 = 1 4.5 \times 10^{-16} N_e \lambda^2 \rightarrow n 1 \propto N_e$

-) Group velocity:
$$V_g = c[1-(\omega_p/\omega)^2]^{1/2} \rightarrow V_g^*V_p = c^2$$

-) Plasma wake:

 $\begin{array}{ll} \underline{\text{Wave breaking field}}: & \mathsf{E}_{_0}(V/m) \cong 96 \; [\mathbf{N}_{_{\mathbf{e}}}(\text{cm}^{\text{-3}})]^{1/2} \\ \underline{\text{Plasma wavelength}}: & \lambda_{_{\mathrm{P}}}(\mu m) \cong 3.3 \times 10^{10} / [\mathbf{N}_{_{\mathbf{e}}}(\text{cm}^{\text{-3}})]^{1/2} \end{array}$



-) <u>Nuclear Fusion</u>: Triple product = **Density** x Temperature x Time

Motivations

A **change of paradigm** is under way in the field of <u>plasma acceleration</u>: after decades of *fundamental research*, *discoveries and break-throug*h in the generation of multi-GeV electron bunches, nowadays much effort is devoted towards the **practical application** \rightarrow the design and realization of <u>user oriented infrastructures</u> (EuPRAXIA: up to 5GeV, <1% energy spread, etc.) and also towards <u>high repetition up to 1 KHz rate sources</u> (Laser and acceleration stages).

This forward step requires a **dedicated approach** aiming at the development of stable and **fully controllable plasma accelerator stages.** In this context, the definition, development and deployment of **robust** and **sensitive** diagnostics is of critical importance to achieve the final goal.

Example: $N_e \sim 5x10^{17}$ cm⁻³ within <10% \rightarrow sensitivity < 5x10¹⁶ cm⁻³

Optical plasma density diagnostics

-) **Interferometry**: quantitative, various configurations, also for neutral gas density N_a (e.g. hydrogen)

-) **Shadowgraphy**: mainly qualitative, sensitive to the second derivative of the density $(\partial^2 N_e / \partial x^2)$

-) **Optical Emission Spectroscopy**: quantitative, simple configuration, no need of through line of sight

Main Interferometric methods

a) Two-arm interferometer



b) Nomarski-type interferometer



ai) Standard two-arm interferometers, e.g., M-Z,

aii) Modified two arm-interferometers Self-referenced, easier to set-up and control

b) Nomarski-type Quasi-common path, self-referenced

$$\Delta \phi = 2\pi / \lambda \int_{I} [n(\lambda, I) - 1] dI \propto \int_{I} N_{e}(I) dI.$$

c) Wave front sensor Easy to implement, sensitive to phase gradient

d) Second-harmonic interferometer

Common path, sensitive to dispersion

Two-arm interferometers examples

-) Standard two-arm interferometers (TAI). laser beam divided into distinct sample and reference arms following different geometrical paths,

$$\Delta \phi = 2\pi/\lambda \int_{L} [n_{g}(\lambda, l) - 1] dl \propto \int_{L} N_{g}(l) dl.$$



J Ju and B Cros J. Appl. Phys. 112, 113102 2012

-) Modified (folded) two-arm interferometers.

Self-referenced





J. Park, HA Baldis, and H Chen, High Pow. Laser Sci. Eng., 4, e26, 2016

R.J. Shalloo, C. Arran, A. Picksley, A. von Boetticher, L. Corner, J. Holloway, G. Hine, J. Jonnerby, H. M. Milchberg, C. Thornton, R. Walczak and S.M. Hooker PHYSICAL REVIEW ACCELERATORS AND BEAMS 22, 041302 (2019)

Gas Cel

Spectral Domain two-arm Interferometry



J. van Tilborg, J. Daniels, A. J. Gonsalves, C. B. Schroeder, E. Esarey, and W. P. Leemans, PHYSICAL REVIEW E 89, 063103 (2014) J. Daniels, J. van Tilborg, A. J. Gonsalves, C. B. Schroeder, C. Benedetti, E. Esarey, and W. P. Leemans, PHYSICS OF PLASMAS 22, 073112 (2015)

Nomarski type interferometers

Self-referenced, quasi common-path



F. Brandi and L.A. Gizzi, High Power Laser Sci. Eng. 7, e26, 2019

WaveFront Sensors: principles

- -) The phase is measured on a wave-front sensing device.
- -) Easy implementation and robustness.
- -) The methodology is sensitive to the transverse gradient of the phase.
- -) Actual phase value is retrieved with a reconstruction algorithm.



K. L. Baker, J. Brase, M. Kartz, S. S. Olivier, B. Sawvel, and J. Tucker Rev. Sci. Instrum., 73, 3784, 2002

-) Quandri-wave lateral shearing achieved with **diffractive elements** commercially available

J.-C. Chanteloup Appl. Opt. 44, 1559 (2005)

WaveFront Sensor - Interferometry



The difference in the measured values is 10-20%. The base noise averaging over 188 maps is 95.7 mrad for the modified M-Z and 11.4 mrad for the WF sensor

G.R. Plateau, N.H. Matlis, C.G.R. Geddes, A.J. Gonsalves, S. Shiraishi, C. Lin, R. A.van Mourik, and W.P. Leemans, Rev. Sci. Instrum. 81, 033108, 2010

Second-Harmonic Interferometry Principles



-) Interference takes place between the two SH beams generated before and after the sample;

-) The measured phase difference is $\Delta \phi = 4\pi / \lambda \int_{L} [n(\lambda) - n(\lambda/2)] dI \propto \int_{L} N_{e}(I) dI$. (compared with $2\pi / \lambda \int_{L} [n(\lambda) - 1] dI$ for two-arm interferometer).

Characteristics:

1) fully common-path \rightarrow easy to implement, insensitive to vibrations enabling high sensitivity; 2) compact, versatile, reliable;

- 3) High-sensitivity and accuracy;
- 4) ultra-fast measurements doable.

F. A. Hopf, A. Tomita, and G. Al-Jumaily, Opt. Lett. 5, 386 (1980). F Brandi and F. Giammanco, Opt. Lett. 2007

Second-Harmonic Interferometry Pulsed gas jet

Series 99 Parker pulsed valve



F Brandi and F. Giammanco, Opt. Express 19, 25479 (2011)

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Measurement within single fringe \rightarrow high Sensitivity ~ 1 mrad, Accuracy ~ 1%, Time resolution ~ 1 µs
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Other application examples:

-) Electron density measurements Rev. Sci. Instrum. 80, 113501 (2009) -) Picosecond SHI and THI

Opt. Lett. **33**, 2071 (2008)

-) High spatial resolution SHI (60 micron)

Laser Phys. Lett. 10, 056003 (2013)



Second-Harmonic Interferometry Pulsed flowing gas cell



Spectral Domain SHI: Application to capillary discharges

1) Common-path design overcome the limitation of two-arm spectral domain interferometry

2) $I(2\omega)=I_1(2\omega)+I_2(2\omega)+[I_1(2\omega)I_2(2\omega)]^{1/2}cos(\Delta \phi - 2\omega \tau) \rightarrow simultaneous$ *delay and phase*measurement*enhance resolution*and can enable*fringe tracking*for high density/long plasma



J van Tilborg, AJ Gonsalves, EH Esarey, CB Schroeder and WP Leemans, Optics Letters 43(12) 2776-2779 (2018) J van Tilborg, AJ Gonsalves, EH Esarey, CB Schroeder and WP Leemans, Phys. Plasmas 26, 023106 (2019)

Spectral Domain SHI: results



Group delay measurement phase sensitivity: 2.84 rad (< $2\pi \rightarrow$ fringe tracking) Spectra phase measurement phase sensitivity: 63 mrad

J. van Tilborg, A. J. Gonsalves, E. Esarey, C. B. Schroeder, and W. P. Leemans, Phys. Plasmas 26, 023106 (2019)

Shadowgraphy Imaging

-) sensitive to the second spatial derivative of $n \rightarrow$ mainly qualitative:

-) some quantitative information - assuming sample geometry and with computational analysis [PHYSICAL REVIEW E 95, 023306 (2017), MF Kasim, L Ceurvorst, N Ratan, J Sadler, N Chen, A Sävert, R Trines, R Bingham, PN Burrows, MC Kaluza, and P Norreys; J. Phys. D: Appl. Phys. 49 (2016) 155204, A Boné, N Lemos, G Figueira and JM Dias]

-) easy to implement in combination with other diagnostics, e.g., interferometry



Imaging design

C. Mauger, L. Mees, M. Michard, A. Azouzi. S. Valette, Exp Fluids (2012) 53, 1895



Straight through shadowgraphy

R. Ono, Y. Teramoto and T. Oda, J. Phys. D: Appl. Phys. 43 (2010) 345203

Shadowgraphy measurements





S Li, Q Zhao, N A M Hafz, S Weng, K Gao, M Mirzaie, G Li, Q Ain and J Zhang, Plasma Phys. Control. Fusion 60 085020 2018



S. Feister, J. A. Nees, J. T. Morrison, K. D. Frische, C. Orban, E. A. Chowdhury, and W. M. Roquemore, Rev. Scient. Instrum. 85, 11D602 (2014)

Stark broadening in Hydrogen

Origin: Broadening of the emission lines due to the effective electric field:

 $N_e = C(N_e,T) \Delta \lambda^{3/2}$

 $C(N_e,T)$ is a slowly varying function of N_e and T, and $\Delta\lambda = FWHM$ of the emission line (e.g., H_{α} at 656.3 nm, and H_{β} at 486.1 nm) [Griem, H.R. Spectral Line Boradening by Plasmas; Academic Press: Cambridge, MA, USA, 1974] <u>Examples</u> (T~ few eV)

NOTES:

1) avoid spurious lines from <u>contaminants</u> (like oxygen, silicon, aluminum, e.g., from ablated capillary material)

2) assume negligible Doppler broadening, e.g., in atomic hydrogen:

$$\Delta \lambda_{doppler} = 7.13 \times 10^{-7} T^{\frac{1}{2}} \lambda$$
, where T is in Kelvin (1 eV = 11604 K)

$$H_{\alpha}$$
, $\lambda = 656.3$ nm, $T = 4 \text{ eV} \rightarrow \Delta \lambda = 0.10$ nm
 H_{β} , $\lambda = 486.1$ nm, $T = 4 \text{ eV} \rightarrow \Delta \lambda = 0.07$ nm

Merits:

can be implemented without a through line of sight and gives an estimate of the local density ILIL, CNR-INO

Stark broadening measurements

Square Discharge capillary: Stark broadening H_g VS Interferometry



D.G. Jang, M.S. Kim, I.H. Nam, H. Jang and H. Suk, J. Instrum. 2012

Stark broadening measurements

Hybrid discharge capillaries: up to 60-mm-long with a diameter of 500 μ m, made of polymethyl methacrylate (PMMA) - H_{α}





Z Qin, W Li, J Liu, J Liu, C Yu, W. Wang, R Qi, Z. Zhang, M Fang, K Feng, Y Wu, L Ke, Y Chen, C Wang, R Li and Z Xu, Phys. Plasmas 25, 073102 (2018)

Stark broadening measurements

3D printed hybrid discharge capillaries - H_a



F. Filippi, M. P. Anania, A. Biagioni, E. Chiadroni, A. Cianchi, Y. Ferber, M. Ferrario, and A. Zigler, REV. SCIENT. INSTRUM. 89, 083502 (2018)

without Hydrogen 484 482 486 488 490 492 nm with Hydrogen 482 484 490 492 486 488 nm x 10¹⁶ 100 discharge current 10 10000 shots * 20000 shots + * 1 30000 shots 50000 shots 8 T ** --

Current [A]

n_e [cm⁻³] 9

2

0 Ò

200

400

600

Time [ns]

800

1000

1200

30

Raman scattering measurements examples

Measurements of the Raman scattering of the laser photons by the plasma: $\omega_{\text{Raman}} = \omega_{\text{laser}} - \omega_{\text{P}} \rightarrow N_{e}[10^{19}\text{cm}^{-3}] = 1.11 \times 10^{8} (1/\lambda_{\text{laser}} - 1/\lambda_{\text{Raman}})^{2}$

Forward scattering in a capillary



Need to resolve Raman scattering radiation \rightarrow relatively high N_e (> 10¹⁸ cm⁻³)

I. Nam, M. Kim, S.-w. Lee, D. Jang and H. Suk J. Korean Phys. Soc. **69**, 957, 2016

Backward scattering in a gas jet



Linear SRS model break-down at high intensity and density

D. Kaganovich, B. Hafizi, J. P. Palastro, A. Ting, M. H. Helle, Y.-H. Chen, T. G. Jones, and D. F. Gordon Phys. Plasmas **23**, 123104 (2016)

Conclusions

-) there is a **plethora of non invasive optical-based methodologies** for density measurements <u>in plasma and neutral gas;</u>

-) Interferometric techniques give a quantitative evaluation of the line integrated density (free electron and neutral gas), require a through line of sight; common path quasi-common path and TAI folded designs are the most suitable to be implemented in a user oriented accelerator facility;

-) Shadowgraphy can be implemented **in parallel with Interferometry**, providing an easy way to monitor the laser produced plasma.

-) **Optical emission spectroscopy** does not require a through line of sight and provide information on the actual **local electron density value**;

-) Finally, a portfolio of different methodologies do exist where to look about optical plasma density diagnostics tools when designing new facilities during Alignment, Tuning and Operation of plasma based acceleration stages, with some R&D required (e.g., ultra-fast time domain SHI)

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